

**REPLY UNDER 37 CFR 1.116** 

**EXPEDITED PROCEDURE** TECHNOLOGY CENTER 2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.

10/064,316

Conf. No.

8270

In Re Application of:

Furukawa et al.

**Art Unit:** 

2811

Serial No.

10/064,316

Dkt. #:

BUR92001022 (IBMB-0010)

Filed:

07/02/2002

Examiner:

Vu, H.

Title:

SEMICONDUCTOR WITH CONTACT

CONTACTING DIFFUSION

ADJACENT A GATE ELECTRODE

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

**AMENDMENT** 

Sir:

## INTRODUCTORY COMMENTS I.

In response to the Office Action of August 20, 2003, please amend the above-referenced patent application as follows: